

<b>Search Notes</b> 	<b>Application No.</b> 10/788,462	<b>Applicant(s)</b> RABITSCH, BENJAMIN FRANKLIN
	<b>Examiner</b> Christopher S. Kim	<b>Art Unit</b> 3752

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
EAST		3/8/2006	CK